



Docket No.: R2184.0247/P247

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Keiichi Yoshioka

Application No.: 10/633,681

Confirmation No.: 6878

Filed: August 5, 2003

Art Unit: 2815

For: SEMICONDUCTOR INTEGRATED
CIRCUIT DEVICE AND FABRICATION
METHOD THEREOF

Examiner: E. J. Wojciechowicz

*Entered
Pr. LEE
filed
9/13/06*

AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INTRODUCTORY COMMENTS

In response to the Office Action dated May 17, 2006, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 8 of this paper.